



# Structure and magnetic properties of $\gamma'$ -Fe<sub>4</sub>N films grown on MgO-buffered Si (0 0 1)

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## ABSTRACT

$\gamma'$ -Fe<sub>4</sub>N thin films were grown on MgO-buffered Si (1 0 0) by pulsed laser deposition technique. Different crystallographic orientations and in-plane magnetic anisotropies were achieved by varying the growth temperature of the MgO buffer layer. When the MgO buffer layer was grown at room temperature, the  $\gamma'$ -Fe<sub>4</sub>N film shows isotropic in-plane magnetic properties without obvious texture; while in-plane magnetic anisotropy was recorded for the  $\gamma'$ -Fe<sub>4</sub>N films deposited on a 600 °C-grown-MgO buffer due to the formation of a (1 0 0)-oriented biaxial texture. Such a difference in in-plane magnetic anisotropy is attributed to the epitaxial growth of  $\gamma'$ -Fe<sub>4</sub>N film on an MgO buffer with relaxed strain when the MgO layer was grown at a high temperature of 600 °C.

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## 1. Introduction

Spin injection from a ferromagnetic (FM) metal into a semiconductor (SC) has been a crucial issue for the applications of spin-based electronics [1–4]. The spin injection efficiency is one of the key factors for the realization of spintronic devices. For a traditional FM/SC junction, the large conductivity mismatch between FM and SCs will severely hinder the spin injection and hence degrade the spin injection efficiency [5]. Recently, the insertion of an MgO tunnel barrier in FM/SC junction was demonstrated to effectively alleviate such conductivity mismatch and improve the spin injection efficiency [2,3,6]. Additionally, due to its good thermal and chemical stability even heated up to 800 °C, MgO was also confirmed as an excellent diffusion barrier for FM/SC interface [7]. Therefore, efficient spin injection can be expected by using a crystalline FM/MgO/SC system due to the high tunnel spin polarization [8–9]. For this purpose, FM/MgO/Si systems have attracted much attention because Si plays a primary role in electronics and possesses a long spin relaxation time [10–12].  $\gamma'$ -Fe<sub>4</sub>N has been considered to be one of the most promising FM materials with large magnetic moments for spintronic devices both theoretically and experimentally [13–16].

However, there have been no reports about the growth and properties of the  $\gamma'$ -Fe<sub>4</sub>N/MgO/Si-based heterostructures so far.

In such  $\gamma'$ -Fe<sub>4</sub>N/MgO/Si-based heterostructures, magnetic anisotropy will have a marked effect on the switching behaviors of the spin injection and magneto-tunneling devices. Crystal quality and surface morphology of the MgO buffer layer, largely determined by the deposition temperature, would play crucial roles in the growth of the  $\gamma'$ -Fe<sub>4</sub>N films and corresponding magnetic anisotropy of  $\gamma'$ -Fe<sub>4</sub>N/MgO/Si system. Therefore, we present here the texture formation and in-plane magnetic anisotropy in  $\gamma'$ -Fe<sub>4</sub>N films with the MgO buffer grown at different temperatures on Si substrates.

## 2. Experimental

$\gamma'$ -Fe<sub>4</sub>N films were deposited on Si (1 0 0) substrates by pulsed laser deposition (PLD) with a KrF (Coherent, COMPerPro201,  $\lambda=248$  nm) excimer laser system. The Si (1 0 0) substrates were cleaned chemically by standard procedures followed by dipping in dilute HF acid solution to get hydrogen terminated oxide-free Si (1 0 0) surface, immediately, before loading into the high vacuum chamber. After the stainless-steel vacuum chamber was evacuated to the order of  $10^{-7}$  Torr, the in-situ deposition of the MgO buffer layer was carried out at room temperature (RT) and 600 °C, respectively. The MgO buffer layer is prepared by ablating a sintered MgO target without additional oxygen gas. In order to

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simplify the description, we use the terms “MgOrt” and “MgO600” to denote MgO buffer grown at RT and 600 °C throughout the paper. The  $\gamma'$ -Fe<sub>4</sub>N films were then grown on the top of the MgO buffer layer at 150 °C by ablating high pure (99.95%) iron target at a nitrogen pressure of  $1.8 \times 10^{-3}$  Torr. The target-to-substrate distance was kept at 60 mm for both the MgO ceramic target and the iron metal target. The focused laser fluence was set at 3 J/cm<sup>2</sup> and 5 J/cm<sup>2</sup> for MgO buffer layers and  $\gamma'$ -Fe<sub>4</sub>N thin films, respectively. The laser frequency was kept at 10 Hz for both films. Structural analysis was performed by x-ray diffraction (XRD, PANalytical X'Pert Pro) with a Cu K $\alpha$  radiation. Film thickness was determined under a Hitachi S-4800 scanning electron microscope (SEM). It has been measured that the layer thickness of the  $\gamma'$ -Fe<sub>4</sub>N and MgO buffer are about 200 nm and 50 nm, respectively. Transmission Electron Microscopy (TEM, FEI Tecnai G2 F20) was used to observe the cross-sectional microstructures. Magnetic properties were measured by a superconducting quantum interference device (SQUID) magnetometer (Quantum Design MPMS) and magneto-optic Kerr effect (MOKE) with the applied magnetic field parallel to the film plane at room temperature.

### 3. Results and discussion

The x-ray diffraction  $\theta$ – $2\theta$  scans was used to investigate the effect of MgO growth temperature on the structure of  $\gamma'$ -Fe<sub>4</sub>N films employing the same deposition parameters. Fig. 1 shows XRD patterns of  $\gamma'$ -Fe<sub>4</sub>N films deposited on the MgO buffer grown at RT (MgOrt) and 600 °C (MgO600), respectively. In both cases, only two peaks from  $\gamma'$ -Fe<sub>4</sub>N (2 0 0) and  $\gamma'$ -Fe<sub>4</sub>N (1 1 1) can be observed except for the (2 0 0) peak from the MgO buffer, which indicates the single-phase  $\gamma'$ -Fe<sub>4</sub>N is obtained for the films. For MgOrt, a weak MgO (2 0 0) peak is shifted to the left which implies that the misfit tensile strain exists in the MgO buffer. As the growth temperature increases to 600 °C, the tensile-strained MgO becomes relaxed with the in-plane lattice constant of 4.214 Å, which is consistent with its bulk value. It can be found that the  $\gamma'$ -Fe<sub>4</sub>N film grown on MgO600 is mainly (1 0 0) oriented while the  $\gamma'$ -Fe<sub>4</sub>N film grown on MgOrt exhibits both strong (1 1 1) and (2 0 0) peaks. This different crystal orientation of the  $\gamma'$ -Fe<sub>4</sub>N films can be attributed to the underlying misfit strain in the MgO buffer determined by the growth temperature. Furthermore, the lattice constant of the  $\gamma'$ -Fe<sub>4</sub>N for both samples was calculated to be  $c=3.81$  Å utilizing the observed (2 0 0) diffraction, which is a little larger than the bulk value of 3.795 Å, indicating tensile strain existed in  $\gamma'$ -Fe<sub>4</sub>N layer probably due to the lattice mismatch between  $\gamma'$ -Fe<sub>4</sub>N and MgO. Based on these results, the MgO growth temperature is a key experimental

parameter which determines the underlying misfit strain, leading to the different crystal orientation of the  $\gamma'$ -Fe<sub>4</sub>N films.

Fig. 2 shows the in-plane M–H curves of  $\gamma'$ -Fe<sub>4</sub>N films grown on MgOrt and MgO600 as measured by the SQUID magnetometer at 300 K. Distinct square-like hysteresis loops with large remnant magnetization and small coercive fields were obtained for both samples. The  $\gamma'$ -Fe<sub>4</sub>N film on MgOrt exhibited a low coercivity of 10 Oe, while a lower coercivity of 5 Oe was recorded when growing  $\gamma'$ -Fe<sub>4</sub>N film on MgO600. The saturation magnetization ( $M_s$ ) of the  $\gamma'$ -Fe<sub>4</sub>N films on both MgOrt and MgO600 is about 1250 emu/cm<sup>3</sup>, the value of which is comparable with those reported previously [15]. The  $M_s$  value was calculated by careful volume calibration of the thin films using cross-sectional TEM measurement. It seems that the deposition temperature of the MgO buffer makes a little effect on the  $M_s$  of  $\gamma'$ -Fe<sub>4</sub>N films.

The in-plane magnetic anisotropies of the  $\gamma'$ -Fe<sub>4</sub>N samples with buffer layers deposited at different temperatures were measured by MOKE. Fig. 3 shows the magnetic hysteresis loops of  $\gamma'$ -Fe<sub>4</sub>N/MgO/Si structures with the magnetic field applied along the four major in-plane axes of the Si (1 0 0). For the  $\gamma'$ -Fe<sub>4</sub>N film grown on the MgOrt, the hysteresis loops along four major directions show the very similar features with a squareness of 0.895, which indicates an in-plane magnetic isotropy (Fig. 3(a)). Oppositely, the  $\gamma'$ -Fe<sub>4</sub>N film grown on the MgO600 exhibit an in-plane magnetic anisotropy (Fig. 3(b)) with the squareness close to 1 along both the [0 0 1] and [0 1 0] directions, which clearly reduced along both the [0 1 1] and [0  $\bar{1}$  1] directions, indicating the cubic anisotropy. The hysteresis loop squareness has been calculated along the [0 1 1], [0 0 1], [0  $\bar{1}$  1], and [0 1 0] directions and found to be 0.831, 0.939, 0.887, and 0.927, respectively. These values further suggest a dominant contribution of the cubic biaxial anisotropy superimposed by a uniaxial anisotropy component.

From the XRD results in Fig. 1, there is no difference of stress state in  $\gamma'$ -Fe<sub>4</sub>N films with different MgO growth temperatures, the effect of stress anisotropy on the difference of this in-plane anisotropy can be excluded. As expected for bulk FCC- $\gamma'$ -Fe<sub>4</sub>N, the cubic easy axes are along [1 0 0], [0 1 0], etc. For  $\gamma'$ -Fe<sub>4</sub>N film on MgO600, the cubic magnetic anisotropy component can be attributed to the high (0 0 1)-oriented texture as shown in Fig. 1(b). In our previous research, the  $\gamma'$ -Fe<sub>4</sub>N films grown on Si (1 0 0) using an Fe buffer have shown an in-plane magnetic isotropy although it has a high (0 0 1)-oriented texture, which was attributed to the fiber texture caused by the amorphous interlayer at the interface of Fe/ $\gamma'$ -Fe<sub>4</sub>N, as was confirmed by HRTEM research [17]. Generally, thin film textures may be categorized into two different types: (1) The so-called fiber textures, the orientation of a certain lattice plane is preferentially parallel to the polycrystalline or amorphous substrate in which the influence of the substrate is minor and the texture is formed mainly by anisotropic growth; (2) biaxial textures, the

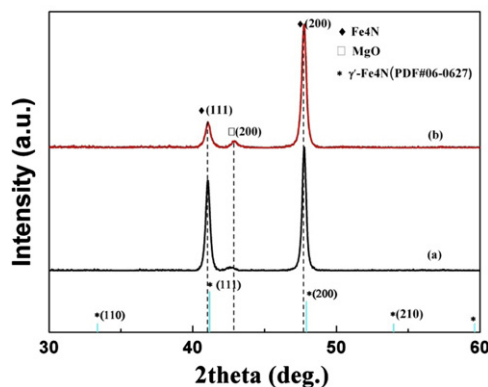


Fig. 1. XRD patterns of two  $\gamma'$ -Fe<sub>4</sub>N/MgO/Si films with MgO buffer grown at (a) RT, (b) 600 °C.

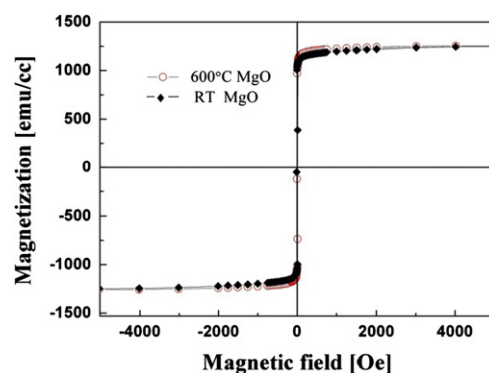


Fig. 2. In-plane magnetic hysteresis loops of the  $\gamma'$ -Fe<sub>4</sub>N films on the MgO layer grown at RT and 600 °C.

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